

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	9	electrode same phosphor same (Si or silicon) same diameter same nm	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/01 08:01
L2	22	phosphor same nm same diameter same (si or silicon)	USPAT	OR	OFF	2007/03/01 08:04
L3	4	phosphor same nm same diameter same (si or silicon)	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/03/01 08:05
L4	177	phosphor same diameter same (si or silicon)	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/03/01 08:08
L5	85	(phosphor same diameter same (si or silicon)) and electrode	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/01 08:15
L6	19	(phosphor same diameter same (si or silicon)) and electrode and "313"/\$.ccls.	USPAT	OR	ON	2007/03/01 08:12
L7	12	(phosphor same diameter same (si or silicon)) and electrode and (EL or electroluminescen\$)	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/03/01 08:34
L8	1	"20010000335"	US-PGPUB; USPAT	OR	OFF	2007/03/01 09:09
L9	0	"20010000335" and nitride	US-PGPUB; USPAT	OR	OFF	2007/03/01 09:12
L10	1	"20010000335" and transistor	US-PGPUB; USPAT	OR	OFF	2007/03/01 09:20
L11	415	"313"/\$.ccls. and (conductive same (film or layer) same nitride)	USPAT	OR	OFF	2007/03/01 09:21
L12	31	"313"/\$.ccls. and (conductive same (film or layer) same nitride same phosphor)	USPAT	OR	OFF	2007/03/01 09:22
L13	1	"313"/\$.ccls. and (conductive same (film or layer) same nitride same phosphor same titanium)	USPAT	OR	OFF	2007/03/01 09:29
L14	383	(EL or electroluminescenc) and (conductive same (film or layer) same nitride same titanium)	USPAT	OR	OFF	2007/03/01 09:29

## EAST Search History

L15	3	(EL or electroluminescenc\$) and (conductive same (film or layer) same nitride same titanium same phosphor)	USPAT	OR	OFF	2007/03/01 09:37
L16	771	(EL or electroluminescenc\$) and (conductive same (film or layer) same ((titanium adj nitride) or TiN) same thickness)	USPAT	OR	OFF	2007/03/01 09:38
L17	440	(EL or electroluminescenc\$) and (conductive same (film or layer) same ((titanium adj nitride) or TiN) same thickness same nm)	USPAT	OR	OFF	2007/03/01 09:38
L18	303	(EL or electroluminescenc\$) and ((conductive adj (film or layer)) same ((titanium adj nitride) or TiN) same thickness same nm)	USPAT	OR	OFF	2007/03/01 09:40
L19	60	(EL or electroluminescenc\$) and ((conductive adj (film or layer)) same ((titanium adj nitride)) same thickness same nm)	USPAT	OR	OFF	2007/03/01 09:55
L20	1	(EL or electroluminescenc\$) and ((conductive adj (film or layer)) same (magnesium adj silver adj alloy) same thickness same nm)	USPAT	OR	OFF	2007/03/01 09:57
L21	3	(EL or electroluminescenc\$) and ((conductive adj (film or layer)) same (magnesium adj silver) same thickness same nm)	USPAT	OR	OFF	2007/03/01 09:57
L22	3	(EL or electroluminescenc\$) and ((conductive adj (film or layer)) same (magnesium same silver same alloy) same thickness same nm)	USPAT	OR	OFF	2007/03/01 09:58
L23	4	(EL or electroluminescenc\$) and ((conductive adj (film or layer)) same (magnesium same silver) same thickness same nm)	USPAT	OR	OFF	2007/03/01 09:59
L24	22	(EL or electroluminescenc\$) and ((conductive adj (film or layer)) same (MgAg) same thickness same nm)	USPAT	OR	OFF	2007/03/01 09:59